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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Satya et al. Attorney Docket No.: KLA1P016F/P642

Application No.: 09/648,095

Examiner: P. Cao

Filed: August 25, 2000

Group: 2811

Title: CHEMICAL MECHANICAL POLISHING TEST STRUCTURES AND METHODS

FOR INSPECTING THE SAME

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on January 2, 2004 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: \

Natalie Morgan

AMENDMENT D

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir-

TC 2800 NAIL ROOP

It is respectfully submitted that the Examiner enters the following amendments in response to the Final Office Action dated 22 October 2003, a response to which is due on 22 January 2004.

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this

Remarks/Arguments begin on page 4 of this paper.